



Attorney Docket No. 0756-7197

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Koichiro TANAKA

Serial No. 10/664,916

Filed: September 22, 2003

For: BEAM HOMOGENIZER AND LASER

IRRADIATION APPARATUS AND

METHOD OF MANUFACTURING

SEMICONDUCTOR DEVICE

) Group Art Unit: 1722

) Examiner: R. Kunemund

) CERTIFICATE OF MAILING

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
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Therefore, no fee is required.

Respectfully submitted,



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Sheet 1 of 1

Complete if Known

Application Number	10/664,916
Filing Date	September 22, 2003
First Named Inventor	Koichiro TANAKA
Group Art Unit	1722
Examiner Name	R. Kunemund
Attorney Docket Number	0756-7197

U.S. PATENT DOCUMENTS

Examiner Initials ¹	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
/RK/		2002/0196419		Mizouchi	12/26/2002	
/RK/		2003/0024905		Tanaka	02/06/2003	
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FOREIGN PATENT DOCUMENTS

Examiner Initials ¹	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁴
		Office ³	Number ³	Kind Code ³ (if known)				
/RK/		CN	1448753			10/15/2003		Full
/RK/		EP	0 747 772			12/11/1996		Abst.
/RK/		EP	0 805 368			11/05/1997		Abst.
/RK/		JP	2003-287703			10/10/2003		Full

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

Examiner Initials ¹	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
/RK/		KAHLERT et al., Poly-Silicon Thin Film Transistor Technology and Applications in Displays and Other Novel Technology Areas, <i>High Resolution Optics For Thin Si-Film Crystallization Using Excimer Lasers: Present Status and Future Development</i> , Vol. 5004 (2003), pp. 20-27.	

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